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GR 99 P 5374

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450:

By: 

Date: Aug 20, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Nicolas Nagel et al.

Applic. No. : 09/729,069

Filed : December 4, 2000

Title : Microelectronic Structure and Method of  
Fabricating it

Examiner : David Vu

Group Art Unit : 2818

A M E N D M E N T

Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

S i r :

Responsive to the Office action dated May 20, 2003 kindly  
amend the above-identified application as follows: